

Filed Via Certified Mail
Rec. No.: 7000 0600 0027 2745 1717
On: October 9, 2001

By: 
Eric L. Maldonado

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No. 100806-17282 (NECK 17.552)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner: Timothy J. Sutton

Art Unit: 2813

October 9, 2001

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
OCT 19 2001
TC 2800 MAIL ROOM

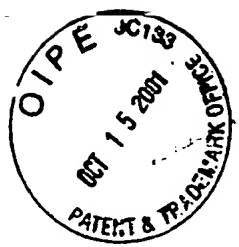
INFORMATION DISCLOSURE STATEMENT

S I R:

In order to comply with discretionary rules 37 CFR §§1.97 and 1.98, attached hereto is a copy of Form PTO-1449 and copies of the documents listed thereon. These documents contain information which the Examiner may consider to be important in deciding whether to issue a patent in the instant application.

As this Statement is being filed prior to issuance of a final Office Action, a fee of \$180.00 accompanies this document in accordance with 37 CFR §§1.97(c) and 1.17(p).

Also attached is a copy of the Examination Report under section 18(3).

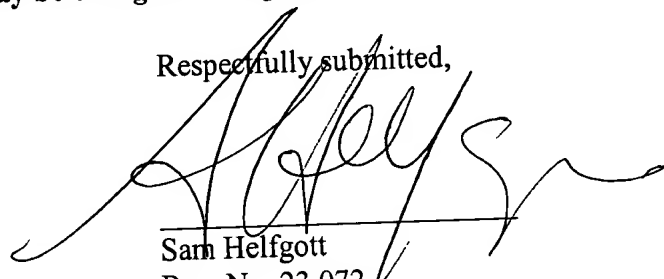


The present Information Disclosure Statement is being submitted in compliance with 37 §CFR 1.56 as an Examiner might consider any cited document important in deciding whether to allow the application to issue as a patent, but the citation of each document is not to be construed as an admission that such document is necessarily relevant or prior art. No representation is intended that the cited documents represent the results of a complete search, and it is anticipated that the Examiner in the normal course of examination, will make an independent search and will determine the best prior art consistent with 37 CFR 1.104 (a) and 1.106 (b), and in the course of such search will review for relevance every document cited on the attached form even if not initialed.

Early and favorable consideration is respectfully solicited.

Any fee due with this paper may be charged on Deposit Account 50-1290.

Respectfully submitted,



Sam Helfgott
Reg. No. 23,072

ROSENMAN & COLIN, LLP
575 MADISON AVENUE
15TH FLOOR
NEW YORK, NEW YORK 10022-2585
(212) 940-8800
DOCKET NO. 100806-17282(NECK 17.552)

**ANY FEE DUE WITH THIS PAPER, NOT FULLY
COVERED BY AN ENCLOSED CHECK, MAY BE
CHARGED ON DEPOSIT ACCOUNT NO. 501290**